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(54) **LOW VOLTAGE INK JET PRINTING MODULE**

NIEDERSPANNUNGS-TINTENSTRAHLMODUL

MODULE D'IMPRESSION PAR JET D'ENCRE A FAIBLE TENSION

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Description

TECHNICAL FIELD

[0001] This invention relates to a method of depositing ink and an ink jet printing module.

BACKGROUND

[0002] An ink jet printing module ejects ink from an orifice in the direction of a substrate. The ink can be ejected as a series of droplets generated by a piezoelectric ink jet printing module. An example of a particular printing module can have 256 jets in four groups of 64 jets each. A piezoelectric ink jet printing module can include a module body, a piezoelectric element, and electrical contacts that drive the piezoelectric element. Typically, the module body is a rectangular member into the surfaces of which are machined a series of ink chambers that serve as pumping chambers for the ink. The piezoelectric element can be disposed over the surface of the body to cover the pumping chambers in a manner to pressurize the ink in the pumping chambers to eject the ink. US 6,217,158 B1 is directed to a piezoelectric vibrator unit including an elastic plate made of piezoelectric material having at least one curved portion. The piezoelectric vibrator unit also includes at least one common electrode and a discrete electrode which are formed on opposite sides of the elastic plate. The application of an electric field applied between the two electrodes causes the extension or contraction of the curved portion of the plate.

Summary

[0003] The aim of the present invention is to provide an improved method for depositing ink and an improved ink jet printing module. This is achieved according to the invention by the method of claim 1 and the module of claim 5. The dependent claims contain preferred embodiments.

[0004] Details are set forth in the accompanying drawings and the description below. Other features and advantages will be apparent from the description and drawings, and from the claims.

DESCRIPTION OF DRAWINGS

[0005]

FIGS. 1A and 1B are schematic diagrams depicting an ink jet printing module.

FIG. 2 is a schematic diagram depicting a portion of an ink jet printing module.

FIG. 3 is a schematic diagram depicting a piezoelectric element.

FIG. 4 is a graph depicting pressure generated in an ink chamber as the thickness of the piezoelectric element and curvature is varied.

FIG. 5 is a graph depicting the change in volume generated in an ink chamber as the thickness of the piezoelectric element and curvature is varied.

FIG. 6 is a schematic diagram depicting a piezoelectric element.

FIG. 7 is a graph depicting pressure generated in an ink chamber as the thickness of the piezoelectric element and curvature is varied.

FIG. 8 is a graph depicting the drop volume generated by an ink chamber as the thickness of the piezoelectric element and curvature is varied.

FIG. 9 is a graph depicting the drop volume generated by an ink chamber as the thickness of the piezoelectric element and curvature is varied.

FIG. 10 is a graph depicting pressure generated in an ink chamber as the thickness of the piezoelectric element and curvature is varied.

FIG. 11 is a graph depicting the drop volume generated by an ink chamber as the thickness of the piezoelectric element and curvature is varied.

DETAILED DESCRIPTION

[0006] An ink jet printing module includes a piezoelectric element positioned over jetting regions of a body. The jetting regions can be portions of pumping chambers within the body. The pumping chambers can be sealed. Electrical contacts, such as electrodes, can be positioned on a surface of the piezoelectric element. The piezoelectric element spans each jetting region. When a voltage is applied to an electrical contact, the shape of the piezoelectric element changes in a jetting region, thereby subjecting the ink within the corresponding pumping chamber to jetting pressure. The ink is ejected from the pumping chamber and deposited on a substrate.

[0007] One example of a piezoelectric ink jet printing module is a shear mode module, such as the module described in U.S. Patent No. 5,640,184, the entire contents of which is incorporated herein by reference. The electrical contacts in a shear mode module can be located on the side of the piezoelectric element adjacent to the ink chamber. Referring to **FIGS. 1A, 1B** and **2**, piezoelectric ink jet head **2** includes one or more modules **4** which are assembled into collar element **10** to which is attached manifold plate **12** and orifice plate **14.** Ink is introduced into module **4** through collar **10.** Module **4** is actuated to eject ink from orifices **16** on orifice plate **14.** Ink jet printing module **4** includes body **20,** which can be made from materials such as sintered carbon or a ceramic. A plurality of chambers **22** are machined or otherwise manufactured into body **20** to form pumping chambers.

[0008] Ink passes through ink fill passage **26,** which is also machined into body **20,** to fill the pumping chambers. Opposing surfaces of body **4** include a series of electrical contacts **31** and **31'** arranged to be positioned over the pumping chambers in body **20.** Electrical contacts **31** and **31'** are connected to leads, which, in turn, can be connected to integrated circuits **33** and **33'.** The components are sealed together to form the print module.

[0009] Referring to **FIG. 2,** piezoelectric element **34** has electrodes **40** on one surface of the piezoelectric element **34.** Electrodes **40** register with electrical contacts **31,** allowing the electrodes to be individually addressed by a driver integrated circuit. Electrodes **40** can be formed by chemically etching away conductive metal that has been deposited onto the surface of the piezoelectric element. Suitable methods of forming electrodes are also described in U.S. Patent No. 6,037,707, which is herein incorporated by reference in its entirety. The electrode can be formed of conductors such as copper, aluminum, titanium-tungsten, nickel-chrome, or gold. Each electrode **40** is placed and sized to correspond to a chamber **22** in body **4** to form a pumping chamber. Each electrode **40** has elongated region **42,** having a length and width slightly narrower than the dimensions of the pumping chamber such that gap **43** exists between the perimeter of electrodes **40** and the sides and end of the pumping chamber. These electrode regions **42,** which are centered on the pumping chambers, are the drive electrodes that cover a jetting region of piezoelectric element **34.** A second electrode **52** on piezoelectric element **34** generally corresponds to the area of body **20** outside chamber **22,** and, accordingly, outside the pumping chamber. Electrode **52** is the common (ground) electrode. Electrode **52** can be comb-shaped (as shown) or can be individually addressable electrode strips. The film electrodes and piezoelectric element electrodes overlap sufficiently for good electrical contact and easy alignment of the film and the piezoelectric element.

[0010] The piezoelectric element can be a single monolithic lead zirconium titanate (PZT) member. The piezoelectric element drives the ink from the pumping chambers by displacement induced by an applied voltage. The displacement is a function of, in part, the poling of the material. The piezoelectric element is poled by the application of an electric field. A poling process is described, for example, in U.S. Patent No. 5,605,659, which is herein incorporated by reference in its entirety. The degree of poling can depend on the strength and duration of the applied electric field. When the poling voltage is removed, the piezoelectric domains are aligned. The piezoelectric element can have a thickness of 5 to 300 microns, 10 to 250 microns, 15 to 150 microns, less than 100 microns, or less than 50 microns.

[0011] Subsequent applications of an electric field, for example, during jetting, can cause a shape change proportional to the applied electric field strength.

[0012] The piezoelectric element can be stiffened, for example, by introducing a curved surface in a portion of the element that covers the ink chamber. The curved surface can have a substantially constant curvature, such as a spherical or cylindrical shape. Referring to FIG. 3, a region **100** of piezoelectric element **34** is curved. The curvature of the piezoelectric element **34** is concave relative to ink chamber **102.** The concave curvature of the surface can reduce buckling that otherwise may occur during jetting. Walls **104** of the chamber **102** can be oriented to contact the stiffened piezoelectric element **34** at an angle of greater than ninety degrees. The chamber can have a width of less than 1200 microns, a width of 50 to 1000 microns, or a width of 100 to 800 microns. Electrodes **42** and **52** are on surface **106** of the piezoelectric element **34.** By applying a jetting voltage across the electrodes, ink within the chamber is subjected to a jetting pressure, which deposits ink from an exit orifice of the ink chamber. For example, the jetting voltage can be less than 60 volts.

[0013] The curved surface has a substantially constant radius of curvature. The degree of curvature, or radius of curvature, affects the stiffness and jetting characteristics of the module. The radius of curvature is the radius of a circle drawn to encompass the curved surface. The curved surface can have a radius of curvature of less than 5 millimeters, or less than 3 millimeters. The curved surface can have a radius of curvature of 500 to 3000 microns, 1000 to 2800 microns, or 1500 to 2600 microns. The curved surface has a spherical shape.

[0014] The ink jet printing module can be prepared by forming a stiffened piezoelectric element, and positioning the piezoelectric element over an ink chamber to subject ink within the chamber to a jetting pressure upon applying a jetting voltage. The stiffened piezoelectric element can be prepared by grinding a curved surface into a thin layer of piezoelectric material or by injection molding a precursor into a mold having the curved surface features of the piezoelectric element. For example, a mixture can be prepared from a piezoelectric material powder and an organic binder. The mixture is injection molded to form a green sheet, which can be heated to remove the binder. The green sheet can be a thin film having a thickness of 10 to 50 microns, or 20 to 40 microns. The powder can be sintered, for example, to at least about 95% of theoretical density. Injection molding to form a piezoelectric article is described, for example, in U.S. Patent No. 5,340,510, which is incorporated by reference in its entirety.

[0015] The curvature stiffens the piezoelectric element and improves jetting of ink when a low voltage is applied to the element. A comparable ink jet printing module having a flat piezoelectric element requires application of a higher voltage to jet an ink drop of comparable volume. A concave surface relative to the chamber can lead to higher positive pressure within the chamber than negative pressure during jetting, for example, a pressure during jetting that can be up to two times higher the pressure during chamber filling. Reducing the dimensions of the ink jet printing module can also lead to higher voltage requirements to achieve a given drop volume. Smaller jets can make the print head more compact. The stiffened element can also allow ink jet modules to be made smaller because the piezoelectric element has a rigidity in at least one dimension that is higher than a flat piezoelectric element. When the piezoelectric element is curved in the resting state, the deflection normal to the piezoelectric element can be amplified relative to a flat plate. Moreover, thinner ink chambers can allow smaller-dimensioned jets having improved performance to be made.

[0016] Finite element analysis modeling of structures having a cylindrical shape (as shown in Fig. 3), a particular radius of curvature, and operated in an extension mode, demonstrated the improved pumping performance of the stiffened piezoelectric element relative to a flat element. In the model, ANSYS multiphysics coupled field analysis (ANSYS Version 5.7, ANSYS Inc. of Canonsburg, PA) was employed using the parameters of an ink chamber diameter of 0.102 cm, an ink chamber depth of 0.152 mm, lead zirconium titanate (PZT 5A, Morgan Electro Ceramics, Bedford, Ohio) poled in the thickness direction, a cavity plate constructed of KOVAR® (a low expansion iron-nickel-cobalt alloy available from High Temp Metals, Inc., Sylmar, CA), land piezoelectric width (the distance between chambers) of 0.254 mm, an ink density of 1000 kg/m^3, a pulse voltage of 50 volts, element thickness ranging from 1 mil (25.4 microns) to 10 mils (254 microns) and a radius of curvature of 30 mils, 40 mils, 50 mils, 100 mils or infinity (flat). The pressures and displacements generated by stiffened piezoelectric elements having particular thicknesses and radii of curvature are listed in Table 1. Pressures and total volume generated by stiffened piezoelectric elements are depicted in Figs. 4 and 5. A comparative example of a flat piezoelectric element at a jetting voltage of 100 volts in shear mode is included as a comparison.

Table 1

Example	PZT Thickness (mils)	Radius of curvature (mils)	Maximum Displacement (μm/μin)	Pressure (Pa/PSI)
1	8 (203 microns)	100 (2.54 mm)	0.0229/0.901	-73424/-10.6
2	5 (127 microns)	100 (2.54 mm)	0.0655/2.61	-122827/-17.8
3	8	50 (1.27 mm)	0.0347/1.36	-96501/-13.9
4	5	50 (1.27 mm)	0.0852/3.35	-172939/-25.1

[0017] Finite element analysis modeling of structures depicted in Fig. 6 having a spherical shape, a particular radius of curvature, operated in extension mode, and a constant total chamber volume also demonstrated the improved pumping performance of the stiffened piezoelectric element relative to a flat element. In this model, ANSYS multiphysics coupled field analysis was employed using the parameters of an ink chamber diameter of 0.102 cm, lead zirconium titanate (PZT 5A) poled in thickness direction, a cavity plate constructed of KOVAR®, land piezoelectric width (the distance between chambers) of 0.254 mm, an ink density of 1000 kg/m^3, a pulse voltage of 50 volts, piezoelectric element thickness ranging from 1 mil (25.4 microns) to 10 mils (254 microns) and a radius of curvature of 20 mils, 30 mils, 40 mils, 50 mils or infinity (flat). The volume of pumping chamber was kept at 3.14 x 10^{-10} m^3, which is same as the total volume in the comparative case. Since the chamber diameter is also a constant (0.102 cm) and the radius of curvature varies, the chamber depth becomes a variable. The chamber depth for each radius of curvature was: R = 20 mil, depth = 2 mil; R = 30 mil, depth =11.33 mil; R = 40 mil, depth =12.59 mil; or R = 50 mil, depth =13.22 mil. The pressures and drop volumes generated by stiffened piezoelectric elements having particular thicknesses and radii of curvature are listed in Table 2. Chamber pressures and drop volumes generated by stiffened piezoelectric elements are depicted in Figs. 7 and 8. A comparative example of a flat piezoelectric element at a jetting voltage of 100 volts in shear mode is included as a comparison.

Table 2

Example	PZT Thickness (mils)	Radius of curvature (mils)	Drop Volume (pL)	Chamber Pressure (PSI)
5	1	50	131.228	87.214
6	1	40	133.948	89.039
7	1	30	129.770	86.219
8	1	20	108.323	71.975
9	2	50	79.418	52.793
10	2	40	79.210	52.621
11	2	30	74.931	49.938
12	2	20	65.243	43.350
13	3	50	52.607	35.003
14	3	40	53.339	35.462
15	3	30	52.048	34.591
16	3	20	47.289	31.421
17	4	50	37.363	24.844
18	4	40	38.614	25.704
19	4	30	38.713	25.760
20	4	20	37.351	24.817
21	5	50	27.841	18.509
22	5	40	29.173	19.464
23	5	30	30.405	20.245
24	5	20	30.862	20.534
25	6	50	21.410	14.270
26	6	40	22.986	15.312
27	6	30	24.595	16.370
28	6	20	26.384	17.548
29	7	50	17.299	11.529
30	7	40	18.723	12.486
31	7	30	20.271	13.555
32	7	20	23.093	15.371
33	8	50	14.300	9.555
34	8	40	15.564	10.393
35	8	30	16.819	11.274
36	8	20	20.519	13.680

(continued)

Example	PZT Thickness (mils)	Radius of curvature (mils)	Drop Volume (pL)	Chamber Pressure (PSI)
Comparative 37[a]	10	Flat	46.221	29.008
[a] 100V driving voltage				

[0018] Additional finite element analysis modeling of structures depicted in Fig. 6 having a spherical shape, a particular radius of curvature, operated in extension mode, and a constant total volume demonstrated the improved pumping performance of the stiffened piezoelectric element relative to a flat element. In this model, ANSYS multiphysics coupled field analysis was employed using the parameters of an ink chamber diameter of 0.102 cm, an ink chamber depth of 0.152 mm, lead zirconium titanate (PZT 5A) poled in thickness direction, a cavity plate constructed of KOVAR®, land piezoelectric width (the distance between chambers) of 0.254 mm, an ink density of 1000 kg/m^3, a pulse voltage of 50 volts, piezoelectric element thickness ranging from 1 mil (25.4 microns) to 8 mils (203 microns) and a radius of curvature of 20 mils, 30 mils, 40 mils, or 50 mils. Since the chamber diameter is also a constant (0.102 cm) and the radius of curvature varies, the chamber depth becomes a variable. The chamber depth for each radius of curvature was: R = 20 mil, depth = 2 mil; R = 30 mil, depth =11.33 mil; R = 40 mil, depth =12.59 mil; or R = 50 mil, depth =13.22 mil. The drop volumes generated by stiffened piezoelectric elements having particular thicknesses and radii of curvature are depicted in Fig. 9.

[0019] Other finite element analysis modeling of structures depicted in Fig. 6 having a spherical shape, a particular radius of curvature, operated in extension mode, and a constant total chamber volume also demonstrated the improved pumping performance of the stiffened piezoelectric element relative to a flat element. In this model, ANSYS multiphysics coupled field analysis was employed using the parameters of an ink chamber diameter of 0.102 cm, an ink chamber depth of 0.152 mm, lead zirconium titanate (PZT 5A) poled in thickness direction, a cavity plate constructed of KOVAR®, land piezoelectric width (the distance between chambers) of 0.254 mm, an ink density of 1000 kg/m^3, a pulse voltage of 15 volts, piezoelectric element thickness of 0.04 mil (1 micron), 0.10 mil (2.5 microns), 0.30 mil (7.5 microns), 0.50 mil (12.5 microns) or 10 mils (254 microns) and a radius of curvature of 30 mils, 40 mils, 50 mils or infinity (flat). Since the chamber diameter is also a constant (0.102 cm) and the radius of curvature varies, the chamber depth becomes a variable. The chamber depth for each radius of curvature was: R = 30 mil, depth =11.33 mil; R = 40 mil, depth =12.59 mil; or R = 50 mil, depth =13.22 mil. The pressures and drop volumes generated by stiffened piezoelectric elements having particular thicknesses and radii of curvature are listed in Table 3. Chamber pressures and drop volumes generated by stiffened piezoelectric elements are depicted in Figs. 10 and 11. A comparative example of a flat piezoelectric element at a jetting voltage of 100 volts in shear mode is included as a comparison.

Table 3

Example	PZT Thickness (mils)	Radius of curvature (mils)	Drop Volume (pL)	Chamber Pressure (PSI)
38	0.04	30	77.121	116.199
39	0.04	40	62.607	94.260
40	0.04	50	51.683	77.890
41	0.10	30	69.069	104.067
42	0.10	40	58.078	87.422
43	0.10	50	48.929	73.738
44	0.30	30	50.714	76.390
45	0.30	40	46.576	70.108
46	0.30	50	41.443	62.445
47	0.50	30	39.929	60.113
48	0.50	40	38.690	58.226
49	0.50	50	35.797	53.901

(continued)

Example	PZT Thickness (mils)	Radius of curvature (mils)	Drop Volume (pL)	Chamber Pressure (PSI)
Comparative 50[a]			29.008	46.221
[a] 100V driving voltage				

[0020] A number of embodiments have been described. Other embodiments are within the scope of the following claims.

Claims

1. A method of depositing ink comprising:

delivering ink to an ink chamber (102); and
applying a jetting voltage across a first electrode (40) and a second electrode (52) on a face of a stiffened piezoelectric element (34) to subject ink within the chamber (102) to a jetting pressure, thereby depositing ink from an exit orifice (16) of the ink chamber (102), wherein the stiffened piezoelectric element (34) has a curved surface over the ink chamber (102), the curved surface having a substantially constant radius of curvature and being concave relative to the ink chamber (102),

characterized in that
the curved surface has a spherical shape and that the stiffened piezoelectric element (34) has a rigidity in two dimensions that is higher than a flat piezoelectric element.

2. The method of claim 1, wherein the piezoelectric element (34) includes lead zirconium titanate.

3. The method of claim 1, wherein the jetting voltage is less than 60 volts.

4. The method of claim 1, wherein the curved surface has a radius of curvature of less than 5 millimeters.

5. An ink jet printing module comprising:

an ink chamber (102);
a stiffened piezoelectric element (34) having a curved surface over the ink chamber (102), the curved surface having a substantially constant radius of curvature and being concave relative to the ink chamber (102), the piezoelectric element (34) being positioned over the ink chamber (102) to subject ink within the chamber (102) to jetting pressure; and
electrical contacts (40, 52) arranged on a surface of the piezoelectric element (34) for activation of the piezoelectric element (34),

characterized in that
the curved surface has a spherical shape and that the stiffened piezoelectric element (34) has a rigidity in two dimensions that is higher than a flat piezoelectric element.

6. The ink jet printing module of claim 5, wherein the piezoelectric element (34) includes lead zirconium titanate.

7. The ink jet printing module of claim 5, wherein the piezoelectric element (34) has a thickness of 5 to 300 microns.

8. The ink jet printing module of claim 5, wherein the piezoelectric element (34) has a thickness of 10 to 250 microns.

9. The ink jet printing module of claim 5, wherein the piezoelectric element (34) has a thickness of less than 100 microns.

10. The ink jet printing module of claim 5, wherein the chamber (102) has a width of less than 1200 microns.

11. The ink jet printing module of claim 5, wherein the chamber (102) has a width of 50 to 1000 microns.

12. The ink jet printing module of claim 5, wherein the chamber (102) has a width of 100 to 800 microns.

13. The ink jet printing module of claim 5, wherein the curved surface has a radius of curvature of 500 to 3000 microns.

14. The ink jet printing module of claim 5, wherein the curved surface has a radius of curvature of 1000 to 2800 microns.

15. The ink jet printing module of claim 5, wherein the curved surface has a radius of curvature of 1500 to 2600 microns.

16. The ink jet printing module of claim 5, wherein the electrodes (40, 52) are configured to apply a voltage of less than 60 volts.

17. The ink jet printing module of claim 5, further comprising a series of chambers (102).

18. The ink jet printing module of claim 17, wherein each of the chambers (102) is covered by a single piezoelectric element.

19. The ink jet printing module of claim 5, wherein the chamber (102) includes a wall (104) contacting the piezoelectric element exposed to the ink chamber (102) at an angle of greater than ninety degrees.

Patentansprüche

1. Verfahren zum Aufbringen von Tinte, umfassend:

   Zuführen von Tinte zu einer Tintenkammer (102); und
   Anlegen einer Ausstoß-Spannung über einer ersten Elektrode (40) und
   einer zweiten Elektrode (52) auf einer Fläche eines versteiften piezoelektrischen Elements (34), um Tinte innerhalb der Kammer (102) einem Ausstoß-Druck auszusetzen, wodurch Tinte von einer Ausgangsöffnung (16) der Tintenkammer (102) aufgebracht wird, wobei das versteifte piezoelektrische Element (34) eine gekrümmte Oberfläche über der Tintenkammer (102) aufweist, wobei die gekrümmte Oberfläche einen im Wesentlichen konstanten Krümmungsradius hat und konkav in Bezug zu der Tintenkammer (102) ist,

   gekennzeichnet dadurch, dass
   die gekrümmte Oberfläche eine sphärische Form hat und das versteifte piezoelektrische Element (34) eine Steifheit in zwei Dimensionen hat, die größer ist als ein flaches piezoelektrisches Element.

2. Verfahren nach Anspruch 1, wobei das piezoelektrische Element (34) Bleizirkoniumtitanat beinhaltet.

3. Verfahren nach Anspruch 1, wobei die Ausstoß-Spannung weniger als 60 Volt beträgt.

4. Verfahren nach Anspruch 1, wobei die gekrümmte Oberfläche einen Krümmungsradius von weniger als 5 Millimetern hat.

5. Tintenstrahldruckmodul, umfassend:

   eine Tintenkammer (102);
   ein versteiftes piezoelektrisches Element (34), das eine gekrümmte Oberfläche über der Tintenkammer (102) aufweist, wobei die gekrümmte Oberfläche einen im Wesentlichen konstanten Krümmungsradius hat und konkav in Bezug auf die Tintenkammer (102) ist, wobei das piezoelektrische Element (34 über der Tintenkammer (102)) positioniert ist, um Tinte innerhalb der Kammer (102) auf einem Ausstoß-Druck auszusetzen; und
   elektrische Kontakte (40, 52), angeordnet auf einer Oberfläche des piezoelektrischen Elements (34) zur Aktivierung des piezoelektrischen Elements (34),

   gekennzeichnet dadurch, dass
   die gekrümmte Oberfläche eine sphärische Form hat und dass das versteifte piezoelektrische Element (34) eine Steifheit in zwei Dimensionen aufweist, die größer ist als ein flaches piezoelektrisches Element.

6. Tintenstrahldruckmodul gemäß Anspruch 5, wobei das piezoelektrische Element (34) Bleizirkoniumtitanat beinhaltet.

7. Tintenstrahldruckmodul gemäß Anspruch 5, wobei das piezoelektrische Element (34) eine Dicke von 5 bis 300 Mikrometern hat.

8. Tintenstrahldruckmodul gemäß Anspruch 5, wobei das piezoelektrische Element (34) eine Dicke von 10 bis 250 Mikrometern hat.

9. Tintenstrahldruckmodul gemäß Anspruch 5, wobei das piezoelektrische Element (34) eine Dicke von weniger als 100 Mikrometern hat.

10. Tintenstrahldruckmodul gemäß Anspruch 5, wobei die Kammer (102) eine Breite von weniger als 1.200 Mikrometern hat.

11. Tintenstrahldruckmodul gemäß Anspruch 5, wobei die Kammer (102) eine Breite von 50 bis 1.000 Mikrometern hat.

12. Tintenstrahldruckmodul gemäß Anspruch 5, wobei die Kammer (102) eine Breite von 100 bis 800 Mikrometern hat.

13. Tintenstrahldmckinodul gemäß Anspruch 5, wobei die gekrümmte Oberfläche einen Krümmungsradius von 500 bis 3.000 Mikrometern hat.

14. Tintenstrahldruckmodul gemäß Anspruch 5, wobei die gekrümmte Oberfläche einen Krümmungsradius von 1.000 bis 2.800 Mikrometern hat.

15. Tintenstrahldruckmodul gemäß Anspruch 5, wobei die gekrümmte Oberfläche einen Krümmungsradius von 1.500 bis 2.600 Mikrometern hat.

16. Tintenstrahldruckmodul gemäß Anspruch 5, wobei die Elektroden (40, 52) angepasst sind, um eine Spannung von weniger als 60 Volt anzulegen.

17. Tintenstrahldruckmodul gemäß Anspruch 5, weiter umfassend eine Reihe von Kammern (102).

18. Tintenstrahldruckmodul gemäß Anspruch 17, wobei jede der Kammern (102) durch ein einzelnes piezoelektrisches Element abgedeckt ist.

19. Tintenstrahldruckmodul gemäß Anspruch 5, wobei die Kammer (102) eine Wand (104) beinhaltet, die das piezoelektrische Element kontaktiert, das in Kontakt ist mit der Tintenkammer (102) in einem Winkel von mehr als 90 Grad.

Revendications

1. Procédé de déposition d'encre, comprenant les étapes consistant à :

   fournir de l'encre dans une chambre à encre (102) ; et
   appliquer un voltage d'éjection entre une première électrode (40) et une seconde électrode (52) sur une face d'un élément piézo-électrique raidi (34) pour soumettre l'encre à l'intérieur de la chambre (102) à une pression d'éjection, en déposant ainsi de l'encre depuis un orifice de sortie (16) de la chambre à encre (102), dans lequel l'élément piézo-électrique raidi (34) possède une surface incurvée au-dessus de la chambre à encre (102), la surface incurvée ayant un rayon de courbure sensiblement constant et étant concave par rapport à la chambre à encre (102),

   caractérisé en ce que
   la surface incurvée possède une forme sphérique, et **en ce que** l'élément piézo-électrique raidi (34) présente une rigidité dans deux dimensions qui est supérieure à celle d'un élément piézo-électrique plat.

2. Procédé selon la revendication 1, dans lequel l'élément piézo-électrique (34) inclut du titanate de plomb-zirconium.

3. Procédé selon la revendication 1, dans lequel le voltage d'éjection est inférieur à 60 V.

4. Procédé selon la revendication 1, dans lequel la surface incurvée possède un rayon de courbure inférieur à 5 mm.

5. Module d'impression à jet d'encre, comprenant :

une chambre à encre (102) ;
un élément piézo-électrique raidi (34) ayant une surface incurvée au-dessus de la chambre à encre (102), la surface incurvée ayant un rayon de courbure sensiblement constant et étant concave par rapport à la chambre à encre (102), l'élément piézo-électrique (34) étant positionné au-dessus de la chambre à encre (102) pour soumettre l'encre dans la chambre (102) à une pression d'éjection ; et
des contacts électriques (40, 52) agencés sur une surface de l'élément piézo-électrique (34) pour l'activation de l'élément piézo-électrique (34),

caractérisé en ce que
la surface incurvée présente une forme sphérique, et **en ce que** l'élément piézo-électrique raidi (34) présente une rigidité dans deux dimensions qui est supérieure à celle d'un élément piézo-électrique plat.

6. Module d'impression à jet d'encre selon la revendication 5, dans lequel l'élément piézo-électrique (34) inclut du titanate de plomb-zirconium.

7. Module d'impression à jet d'encre selon la revendication 5, dans lequel l'élément piézo-électrique (34) a une épaisseur de 5 à 300 microns.

8. Module d'impression à jet d'encre selon la revendication 5, dans lequel l'élément piézo-électrique (34) a une épaisseur de 10 à 250 microns.

9. Module d'impression à jet d'encre selon la revendication 5, dans lequel l'élément piézo-électrique (34) a une épaisseur inférieure à 100 microns.

10. Module d'impression à jet d'encre selon la revendication 5, dans lequel la chambre (102) a une largeur inférieure à 1200 microns.

11. Module d'impression à jet d'encre selon la revendication 5, dans lequel la chambre (102) a une largeur de 50 à 1000 microns.

12. Module d'impression à jet d'encre selon la revendication 5, dans lequel la chambre (102) a une largeur de 100 à 800 microns.

13. Module d'impression à jet d'encre selon la revendication 5, dans lequel la surface incurvée a un rayon de courbure de 500 à 3000 microns.

14. Module d'impression à jet d'encre selon la revendication 5, dans lequel la surface incurvée a un rayon de courbure de 1000 à 2800 microns.

15. Module d'impression à jet d'encre selon la revendication 5, dans lequel la surface incurvée a un rayon de courbure de 1500 à 2600 microns.

16. Module d'impression à jet d'encre selon la revendication 5, dans lequel les électrodes (40, 52) sont configurées pour appliquer un voltage inférieur à 60 V.

17. Module d'impression à jet d'encre selon la revendication 5, comprenant en outre une série de chambres (102).

18. Module d'impression à jet d'encre selon la revendication 17, dans lequel chacune des chambres (102) est couverte par un unique élément piézo-électrique.

19. Module d'impression à jet d'encre selon la revendication 5, dans lequel la chambre (102) inclut une paroi (104) en contact avec l'élément piézo-électrique exposé vers la chambre à encre (102) sous un angle supérieur à 90°.

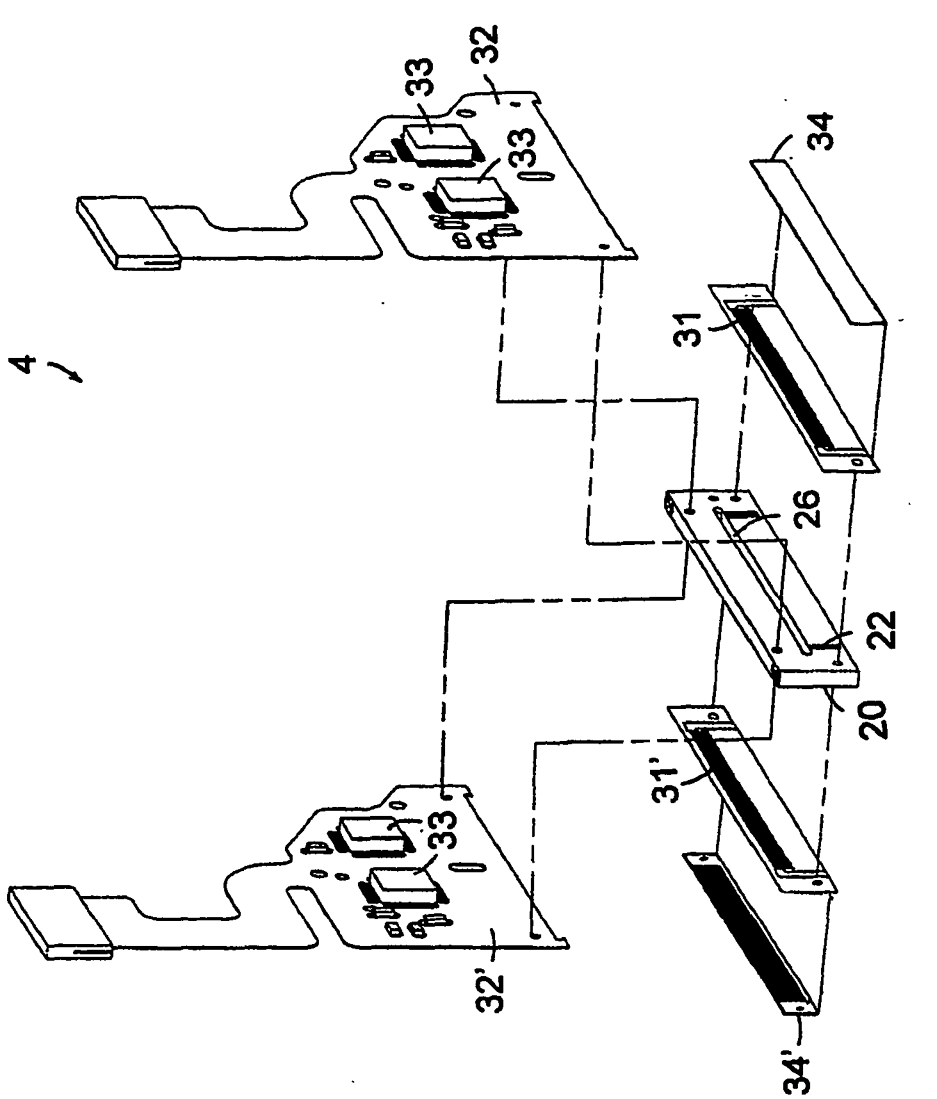

FIG. 1B

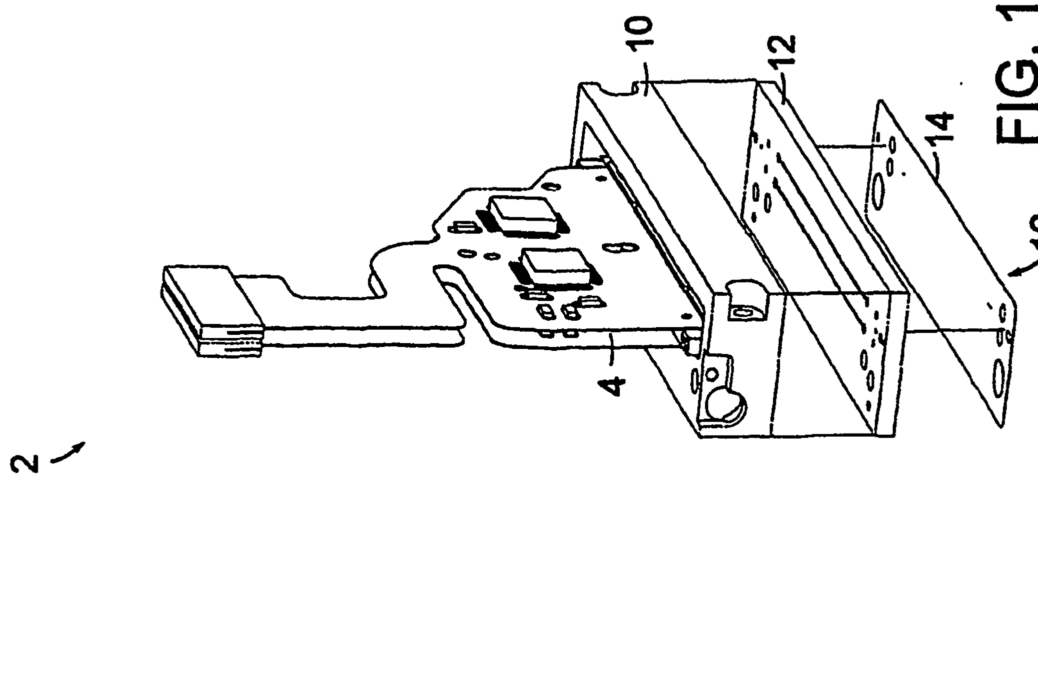

FIG. 1A

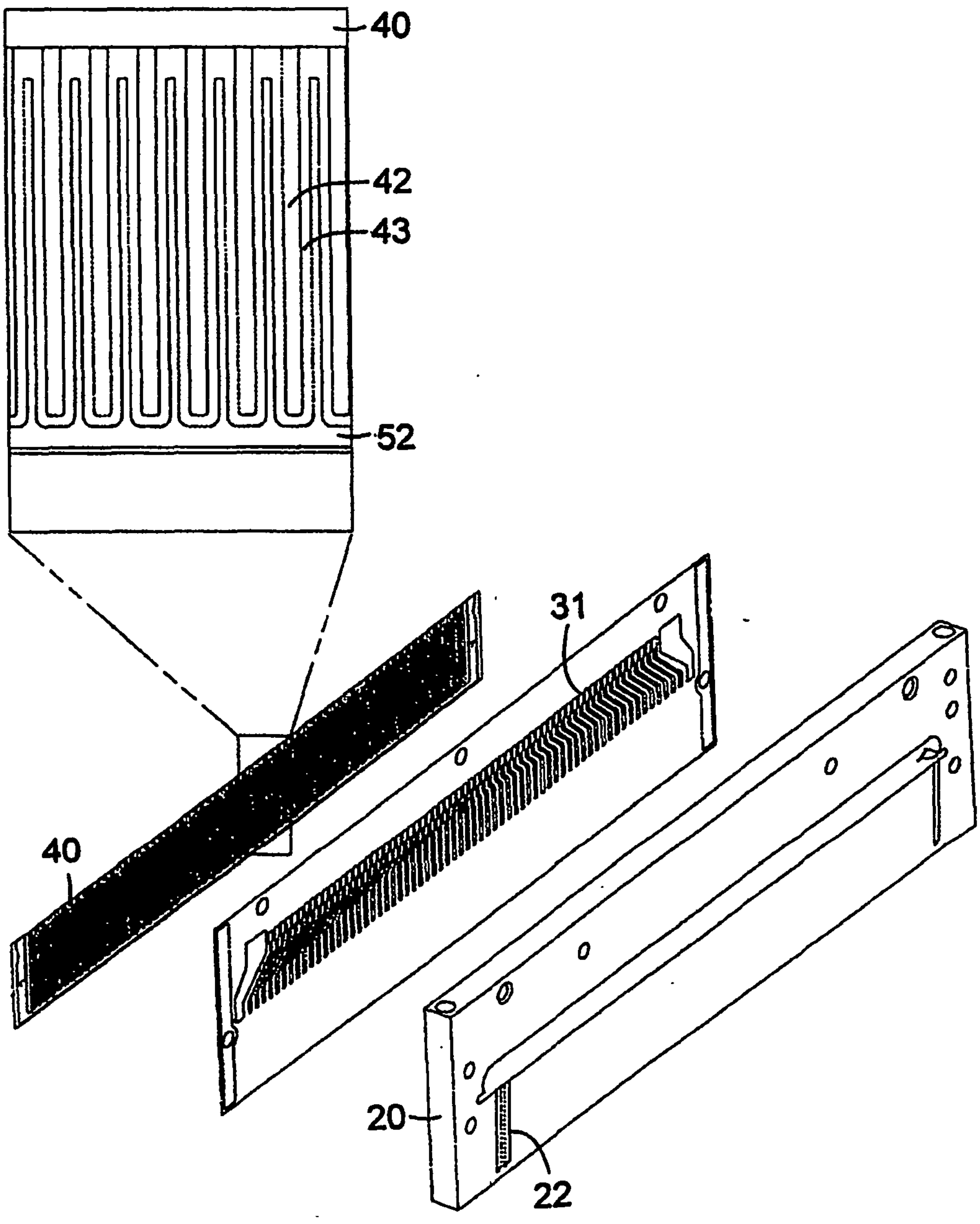

FIG. 2

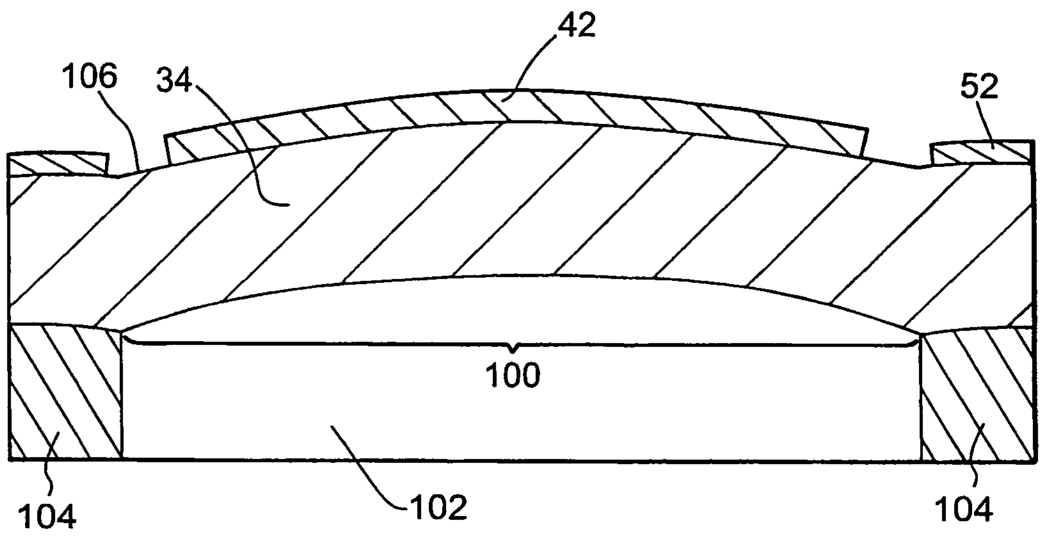

FIG. 3

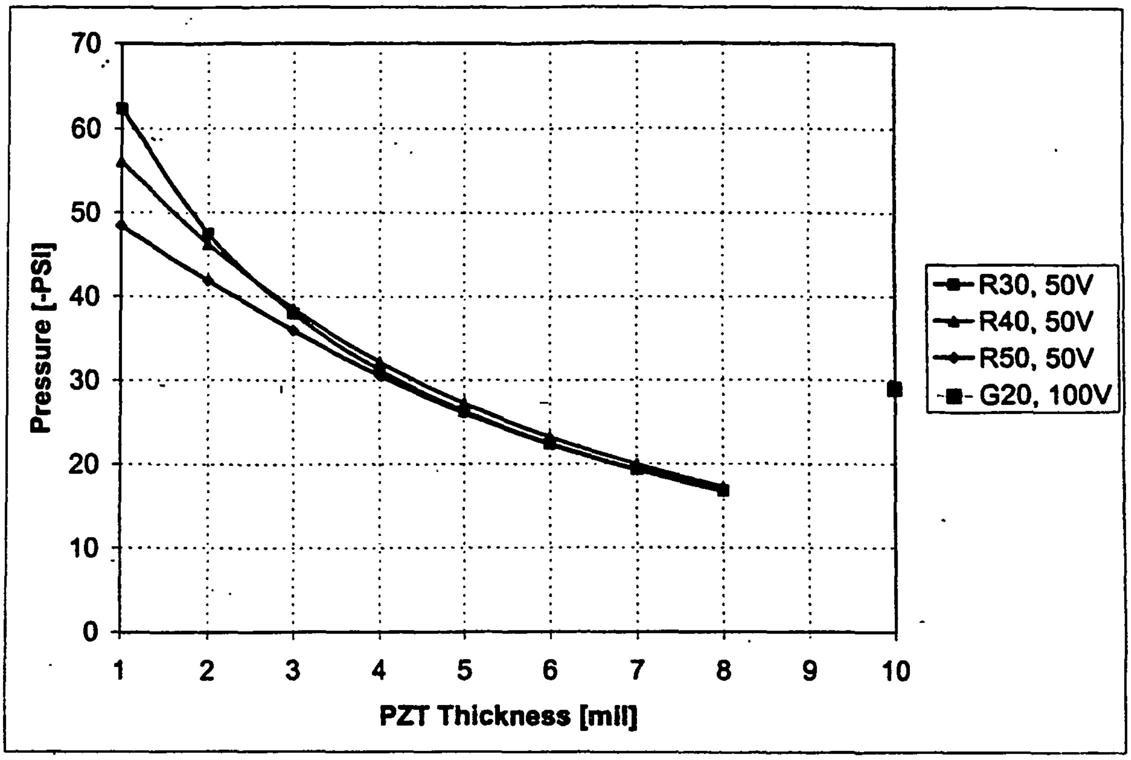

FIGURE 4

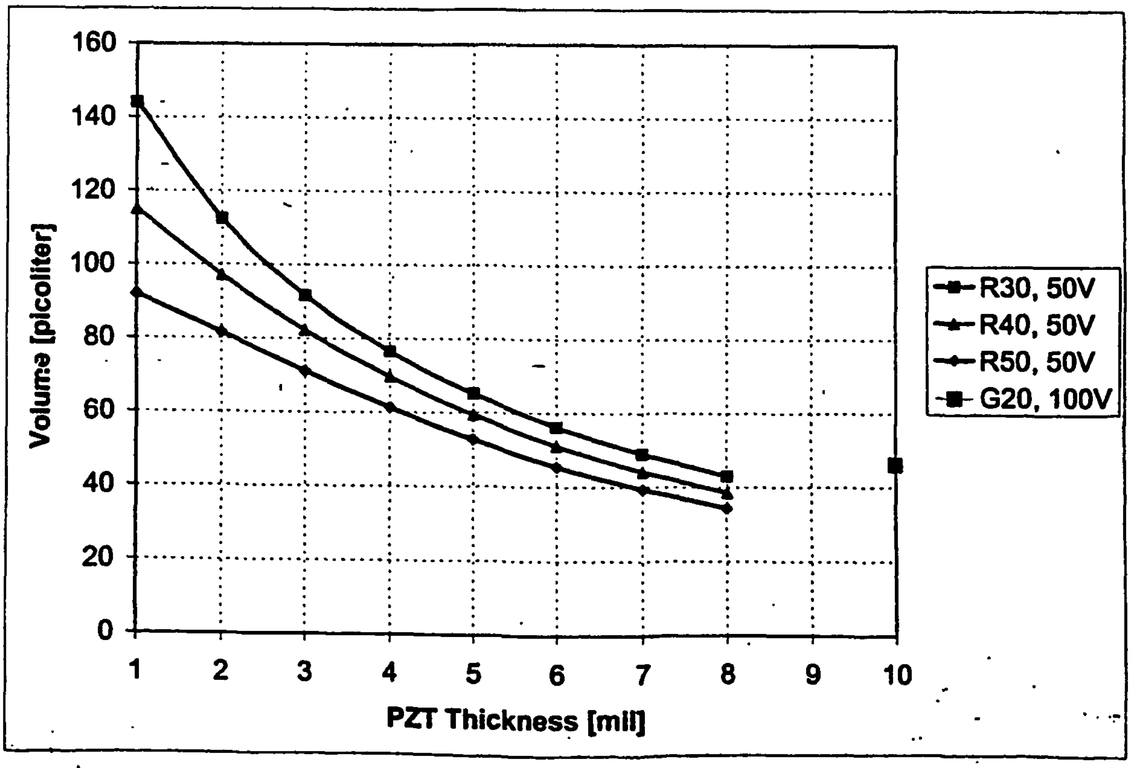

FIGURE 5

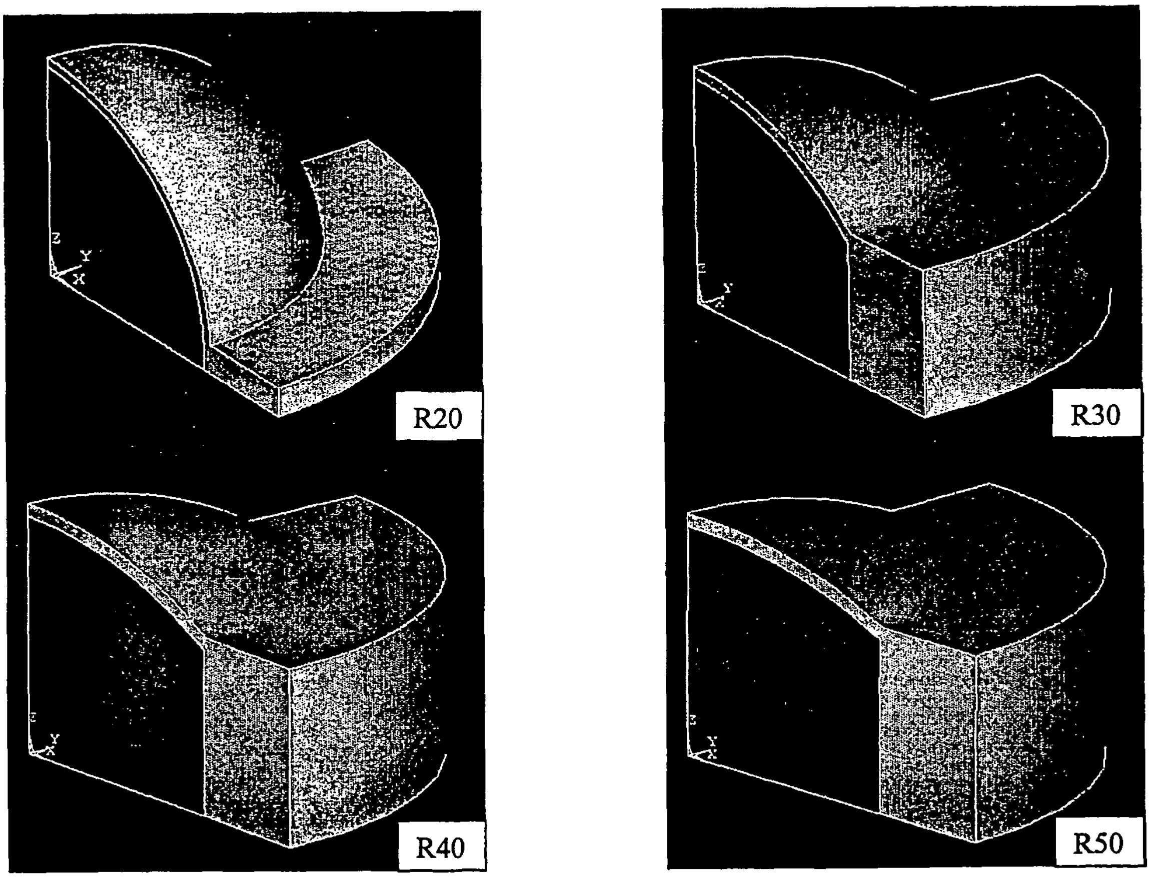

FIGURE 6

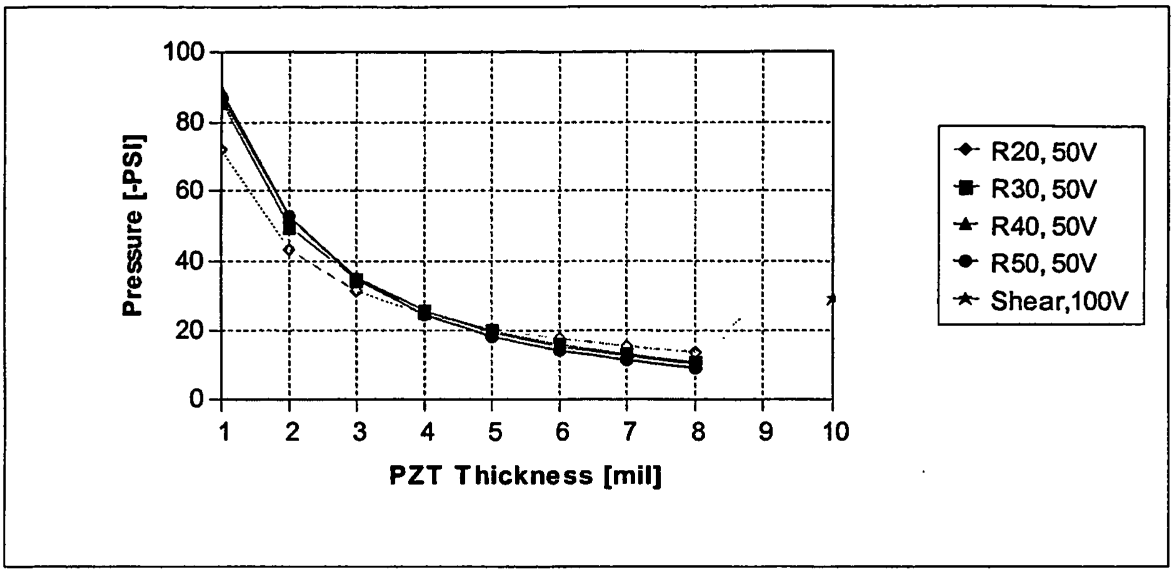

FIGURE 7

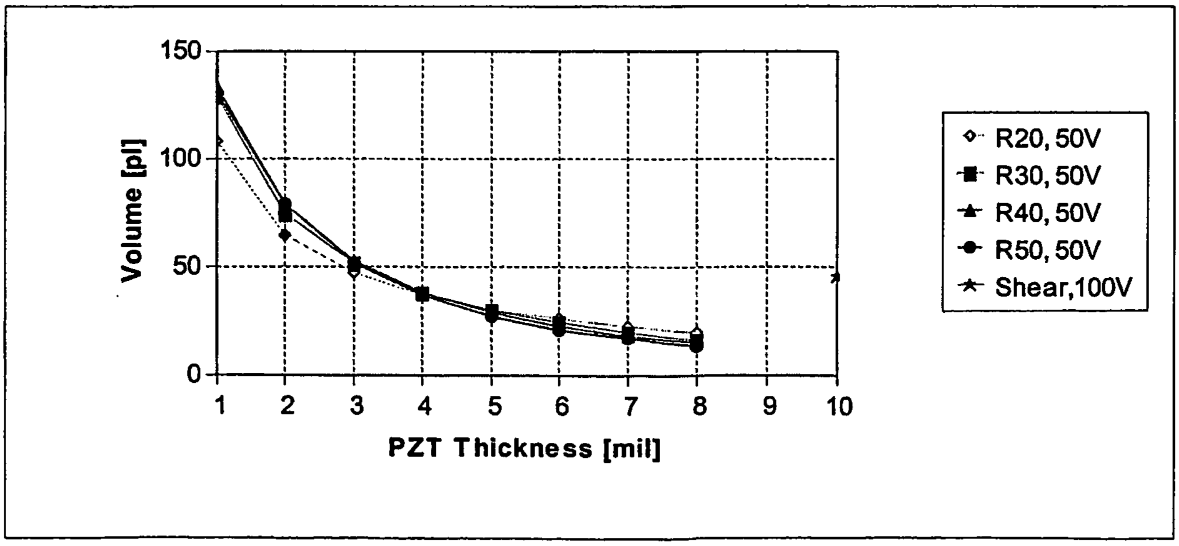

FIGURE 8

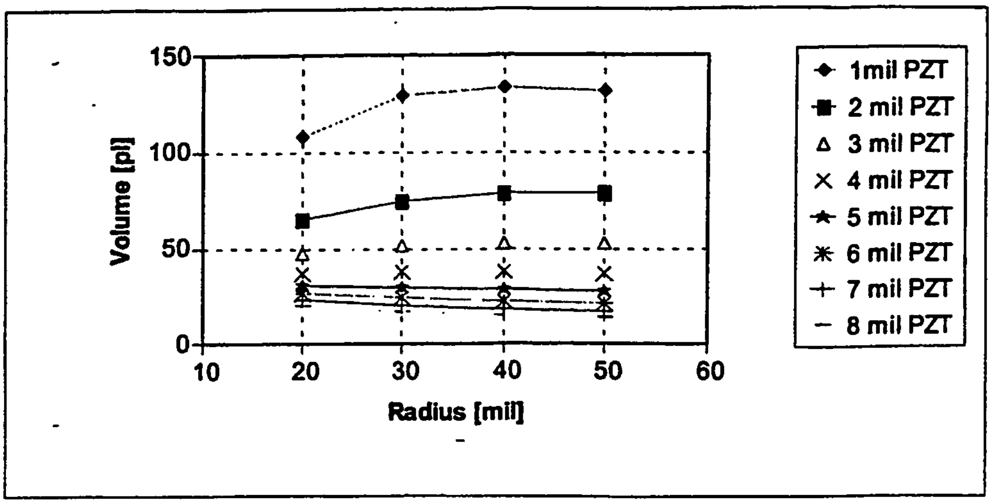

FIGURE 9

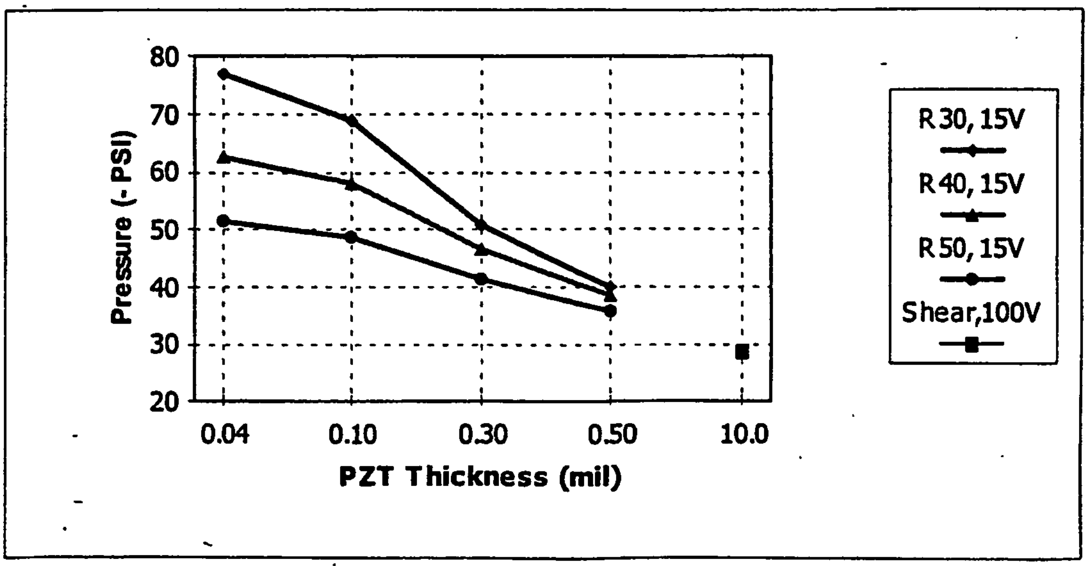

FIGURE 10

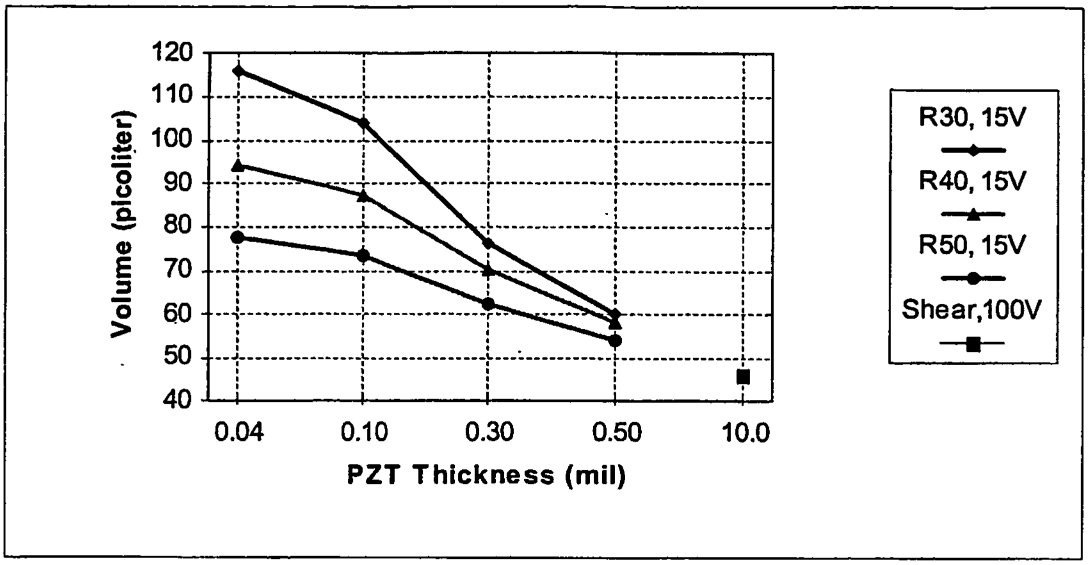
120
110
100
90
80
70
60
50
40
Volume (picoliter)
0.04
0.10
0.30
0.50
10.0
PZT Thickness (mil)
R30, 15V
R40, 15V
R50, 15V
Shear,100V

FIGURE 11

REFERENCES CITED IN THE DESCRIPTION

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